

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	6	wafer with pattern with project\$4 with (flat or notch) with position and exposure	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/04 14:35
L2	1256	702/150	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/04 14:35